



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shyue-Ming JANG et al. Confirmation No: 1807
Appl. No. : 10/660,715
Filed : September 12, 2003
Title : APPARATUS AND PROCESS FOR VACUUM
SUBLIMATION

TC/A.U. : 1793
Examiner : B.M. Martinez

Docket No.: : JANG3005/REF/JDG
Customer No: : 23364

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of January 26, 2009, in connection with the above identified application. Applicant submits herewith a Petition for Extension of Time (One Month) and necessary fees as a necessary submission in response to the Office Action. This response is timely filed.

Please amend the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.